

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In Re PATENT APPLICATION OF:

Applicants : Akio NAKAMURA

Serial No. : To Be Assigned

Filed : November 14, 2003

For : SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Attorney Ref. : SAT 198

INFORMATION
DISCLOSURE
STATEMENT

November 14, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

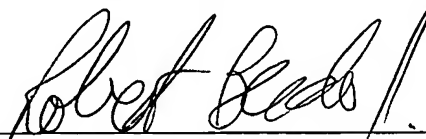
Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached is a copy of one Japanese publication. Any relevance of the Japanese publication can be gleaned from the attached English-language Abstracts, and from page 1 of the present application, where this document is discussed. The publication is listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted and listed document is respectfully requested.

Respectfully submitted,



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November 14, 2003

Date

RHB:tz

FEE ENCLOSED: \$810
Please charge any further
fee to our Deposit Account
No. 18-0002

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT			Atty Docket		Application No.		
			SAT 189		To Be Assigned		
			Applicant				
				Akio NAKAMURA			
			Filing Date		Group Unit		
			November 14, 2003		To Be Assigned		
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AK	2001-210743	08/03/02	Japan			Abstract
	AL						
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
	AP						
	AQ						
	AR						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							